EQUIPMENT DETAILS:

A HARD DISK DRIVE WILL BE REMOVED FROM TOOL.

[Chamber A]
Process: P-TEOS
Hard: CVD
Gas(sccm): Ar(7000), Ar(500), He(2000), N2(5000), NF3(3000), O2(3000), TEOS(300)
RPU: 400kHz/3000W
HRF: 13.56MHz/1000W
LRF: 430kHz/1000W

[Chamber B]
Process: P-TEOS
Hard: CVD
Gas(sccm): Ar(7000), Ar(500), He(2000), N2(5000), NF3(3000), O2(3000), TEOS(300)
RPU: 400kHz/3000W
HRF: 13.56MHz/1000W
LRF: 430kHz/1000W

[Chamber C]
Process: P-TEOS
Hard: CVD
Gas(sccm): Ar(7000), Ar(500), He(2000), N2(5000), NF3(3000), O2(3000), TEOS(300)
RPU: 400kHz/3000W
HRF: 13.56MHz/1000W
LRF: 430kHz/1000W

Other missing or damaged parts: Not reported.